



**ELECTRONIC COPY**

LG636481050  
Report verification at igi.org



May 25, 2024

IGI Report Number **LG636481050**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **8.44 X 6.01 X 4.06 MM**

**GRADING RESULTS**

Carat Weight **2.06 CARATS**

Color Grade **D**

Clarity Grade **VS 1**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

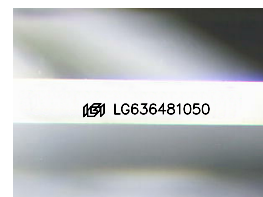
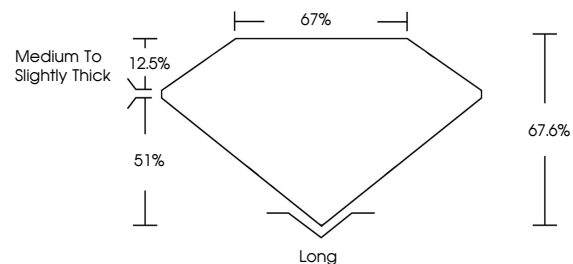
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG636481050**

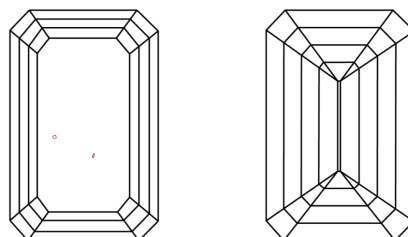
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

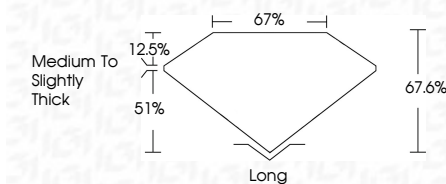
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**

May 25, 2024  
IGI Report No. LG636481050  
**EMERALD CUT**

**2.06 CARATS**  
D

Carat Weight **2.06 CARATS**  
Color Grade **D**  
Clarity Grade **VS 1**  
Depth **51%**  
Table **12.5%**  
Girdle **Medium to Slightly Thick**

Culet **Long**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
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